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PATENT NUMBER and ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU 79		EXAMI	NER		
10076333	02/19/2002	313	607	2812	5	Dario			
**APPLICANTS: Yamada Hitoshi; Tokai Akira; Ishimoto Manabu; Shinoda Tsutae;									
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**CONTINUIN	G DATA VERIFIED):							
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** FOREIGN A	PPLICATIONS VE	RIFIED:							
JAPAN 2001-2	32449 07/31/2001				•				
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Foreign priority cla			s 🗆 no		ATTO	ORNEY DOC	KET NO		
35 USC 119 condit Verified and Ackno	ions met wledged Examiners's it	•	s 🗆 no		1082	2.1042			
TITLE: Gas discharge tube and method for forming electron emission layer in gas discharge tube									
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NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED				
		Assistant Examiner	Total Claims		Print Claim for O.G		
ISSUE FEE				DRAWING			
Amount Due	Date Pald		Sheets Drwg.	Figs.Drwg.	Print Fig.		
		Primary Examiner					
TERMINAL		PREPARED FOR ISSUE	Application Examiner				
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